

Measurements of fluoride production in **Resistive Plate Chambers**

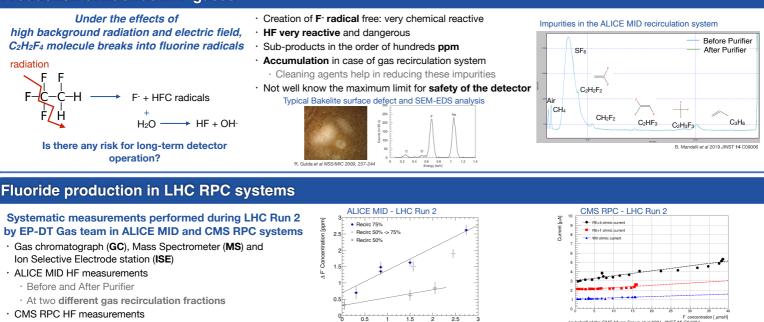
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Detector Technologies

Production of fluoride in F-gases



- Sampling in Barrel and Endcap regions: different radiation background
- Sub-products in the order of tens ppm

Experimental set-up

Ion Selective Electrode (ISE) station

· It measures fluoride ions in aqueous solutions

- · When the F- sensing element is in contact with a solution containing fluoride ions, an electrode potential develops
- The potential depends on the level of free fluorine ions in solution (Nernst equation)

Addition of 30% CO2 to standard gas mixture

Gas mixture is bubbled in water+TISAB II solution

Bubbling efficiency in trapping the HF



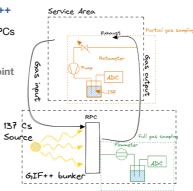
HF production in C₂H₂F₄ based gas mixtures

Currents very similar to std gas mixture at working point

Is the HF production proportional to the quantity of C₂H₂F₄?

HF production measurements at GIF++

- · Test performed at GIF++ by irradiating 2 RPCs detectors with 662 keV gamma
 - · Scan in HV and at different ABS
 - · Measurements performed at working point
 - · Gas analyzed at the output of the irradiated detector
- Optimization of the existing methods: increase the accuracy of measurements by improving parameter monitoring and measurements procedure
- Different types of electrodes tested
- · Gas sampling inside and outside bunker
- · Partial gas sampling or full gas sampling

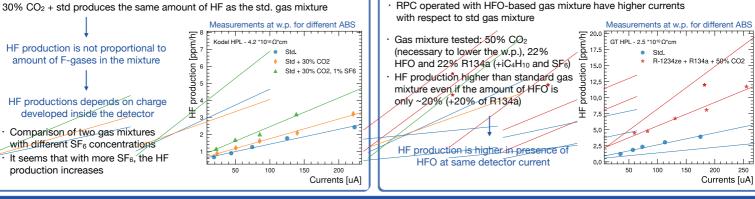




HF production in presence of HFO

What is the different between HFO (C₂H₃F₄) and R134a (C₂H₂F₄)?

- HFOs have a very short atmospheric lifetime
- They are destroyed easier than C₂H₂F₄ RPC operated with HFO-based gas mixture have higher currents



Conclusions

The HF production in the RPCs has to be carefully evaluated and taken into account for the long-term operation. During LHC Run 2, the HF production was measured in the ALICE and CMS RPC systems, confirming the previous results obtained in laboratory condition: HF production is proportional to radiation dose and detector currents. It has been demonstrated that the HF production cannot be lowered by simply adding an inert gas to the standard gas mixture since it is not proportional to amount of Fgases in the mixture. Furthermore, the usage of HFO gases in the future has to be carefully evaluated for the long-term operation as the HF production will be higher with respect to the standard gas mixture even if HFO will be used in lower concentrations.

osity [pb⁻¹] · Higher recirculation fraction: higher concentration of impurities Impurities increase with integrated luminosity

· W0 and RE+1 lower background, lower HF, lower ohmic current increase • RF+4

higher background, higher HF, higher ohmic current increase